



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Sandhu et al.

Serial No.: 10/637,107

Filed: August 8, 2003

For: LOW RESISTANCE CONTACT TO
SILICON HAVING A TITANIUM SILICIDE
INTERFACE AND AN AMORPHOUS
TITANIUM CARBONITRIDE BARRIER
LAYER

Confirmation No.: 5081

Examiner: M. Wilczewski

Group Art Unit: 2822

Attorney Docket No.: 2269-3264.5US
(92-0280.08/US)

Notice of Allowance Mailed:

September 24, 2004

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P.O. Box 1450
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Sir:

Please amend the above-referenced application as follows:

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Abstract appear on page 7 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 8 of this paper.

Remarks begin on page 11 of this paper.